

HIGH TEMPERATURE PROTONIC CONDUCTORS

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High Temperature Protonic Conductors (HTPC) with the perovskite structure are envisioned for electrochemical membrane applications such as H₂ separation, H₂ sensors and fuel cells. Successive membrane commercialization is dependent upon addressing issues with H₂ permeation rate and environmental stability with CO₂ and H₂O. HTPC membranes are conventionally fabricated by solid-state sintering. Grain boundaries and the presence of intergranular second phases reduce the proton mobility by orders of magnitude than the bulk crystalline grain. To enhanced protonic mobility, alternative processing routes were evaluated. A laser melt modulation (LMM) process was utilized to fabricate bulk samples, while pulsed laser deposition (PLD) was utilized to fabricate thin film membranes .

Sr₃Ca_{1+x}Nb_{2-x}O₉ and SrCe_{1-x}Y_xO₃ bulk samples were fabricated by LMM. Thin film BaCe_{0.85}Y_{0.15}O₃ membranes were fabricated by PLD on porous substrates. Electron microscopy with chemical mapping was done to characterize the resultant microstructures. High temperature protonic conduction was measured by impedance spectroscopy in wet air or H₂ environments. The results demonstrate the advantage of thin film membranes to thick membranes but also reveal the negative impact of defects or nanoscale domains on protonic conductivity.

High Temperature Protonic Conductors

F.W. Dynys

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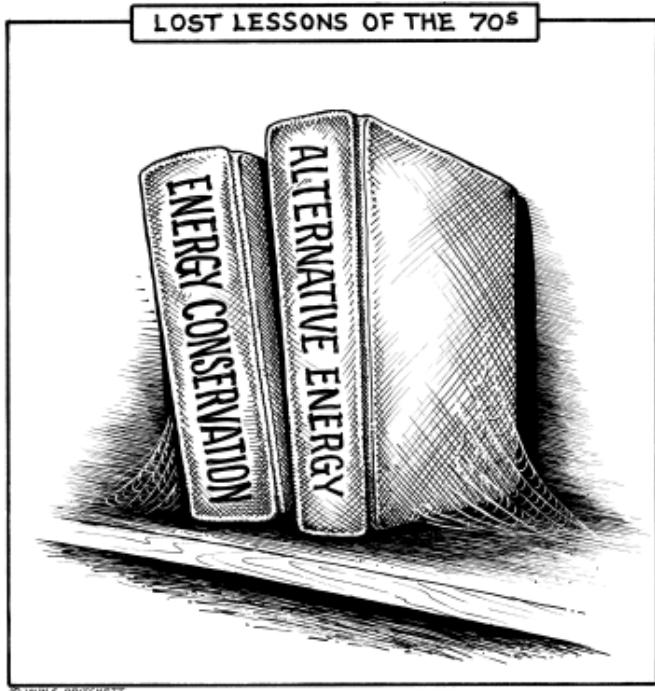
Ecole des Mines de Paris

A.Sayir

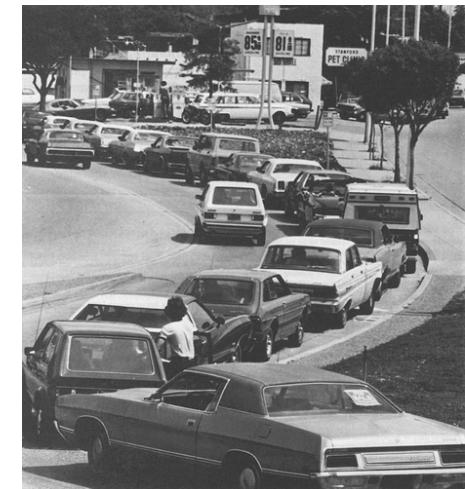
CWRU/NASA-Glenn Research Center

Sponsors: NASA Glenn Research Center Internal Research and Development Program.

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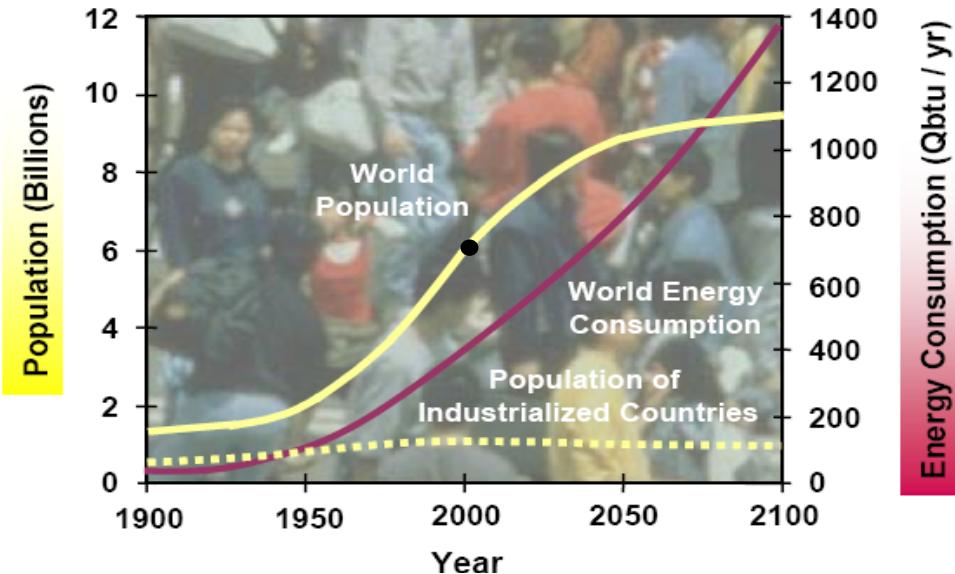


- # Outline
- A. Introduction
 - B. Sintering
 - $\text{BaCe}_{0.85}\text{Y}_{0.15}\text{O}_{3-\delta}$
 - C. Directional Solidification
 - $\text{SrCe}_{0.9}\text{Y}_{0.1}\text{O}_{3-\delta}$
 - $\text{Sr}_3\text{Ca}_{1.18}\text{Nb}_{1.82}\text{O}_{9-\delta}$
 - D. Thin Film Deposition
 - $\text{BaCe}_{0.85}\text{Y}_{0.15}\text{O}_{3-\delta}$
 - D. Summary





World Energy Demand Growing Dramatically



Challenges

- Renewable energy supply will be essential:
Wind, Solar, Bio-fuels Geothermal & Solar thermal
- New forms of energy are vital: H₂
- New sources: Methane hydrates
- Improve efficiency: Extend finite resources
- Technology: Drive energy cost reduction



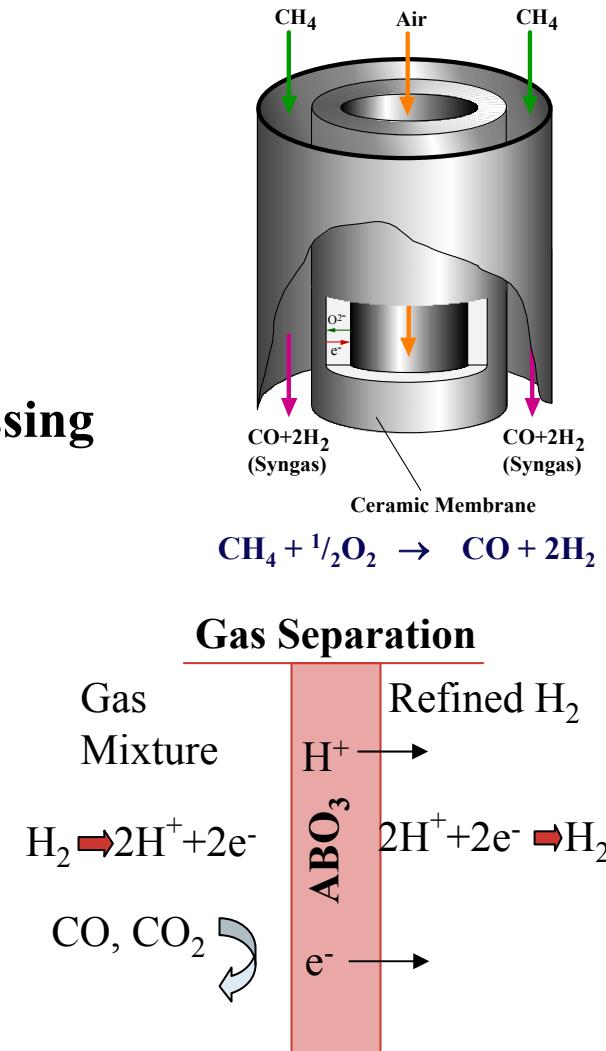
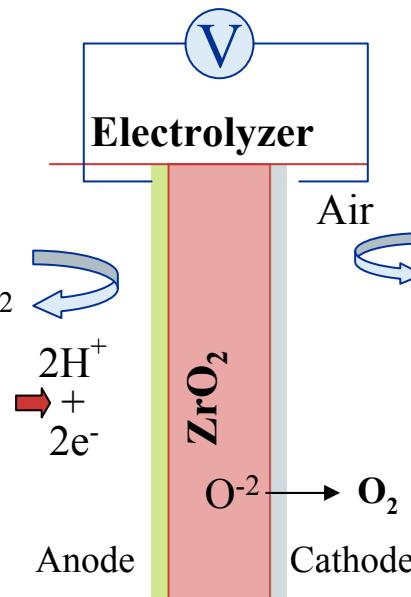
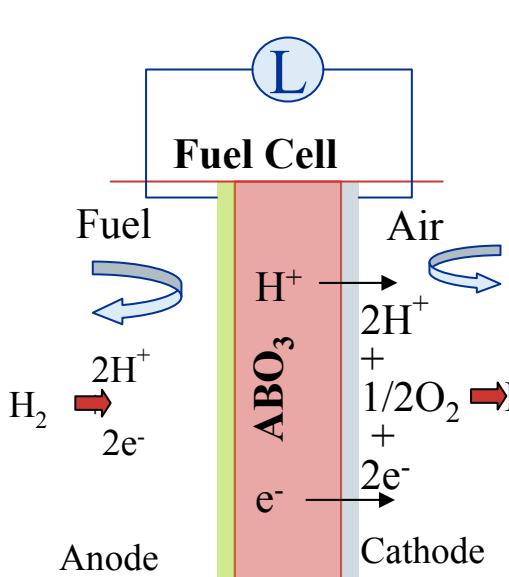
Functional Oxide Materials for Energy Applications

Oxide ceramics – Electrochemical properties

- Oxygen transport – selectivity >1000
- H₂ transport – selectivity >1000

Applications

- Sensors - CO, CO₂, H₂, NO_x detection
- Power - Solid oxide fuel cells
- Electrolyzers
- Membrane reactors – chemical processing

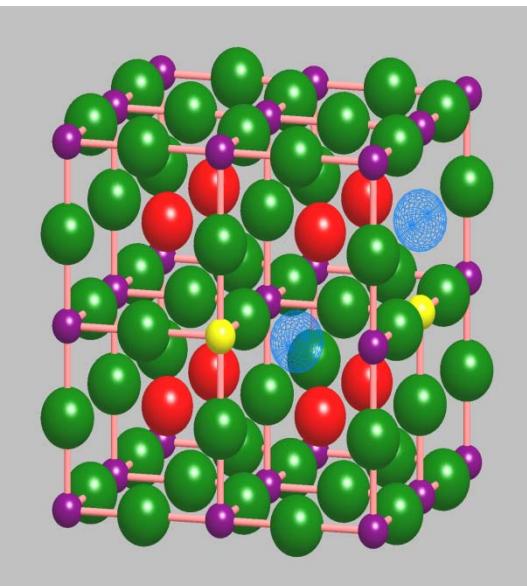




High Temperature Protonic Ceramics

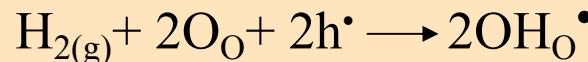
Crystal Structures: Perovskite - ABO_3 , $\text{A}_2(\text{B}' \text{B}^{\prime\prime})\text{O}_{6-\delta}$ & $\text{A}_3(\text{B}' \text{B}_2^{\prime\prime})\text{O}_{9-\delta}$
Fluorite - M_2O_3
Pyrochlore - $\text{A}_2\text{B}_2\text{O}_7$

ABO_3 – $\overline{\text{Pm}}3\text{m}$



Proton Insertion

Oxygen vacancies ($\text{V}_\text{O}^{\bullet\bullet}$) needed for H^+ transport:



Proton strongly associates with a neighbouring oxygen ion-represented as OH



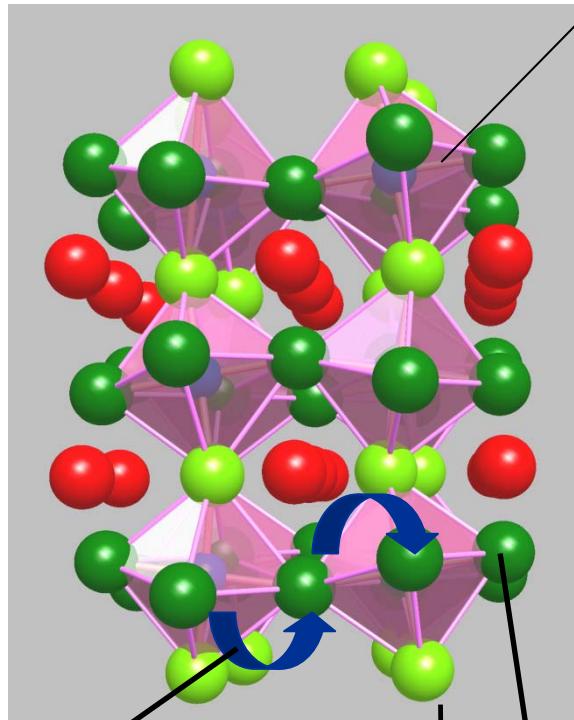
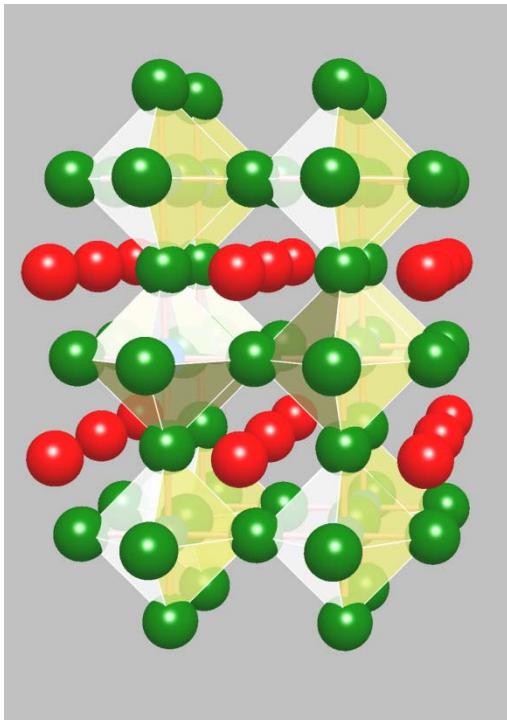
Distorted Perovskite Structure

$$\text{tolerance factor} = \frac{R_A + R_O}{\sqrt{2} \cdot (R_B + R_O)} \quad t < 0.96 \text{ tetragonal/orthorhombic}$$

Cubic

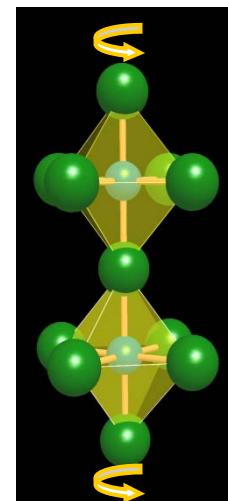


Non-Cubic

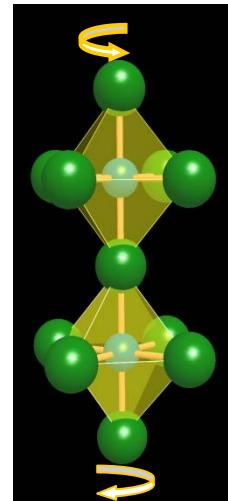


Octahedra Tilting

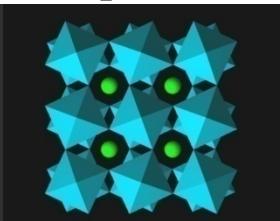
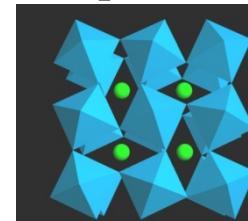
- BO_6 octahedra tilt to reduce A site volume
- SrCeO_3 11° & 12.5°
- BaCeO_3 6° & 8.8°



In-phase



Antiphase

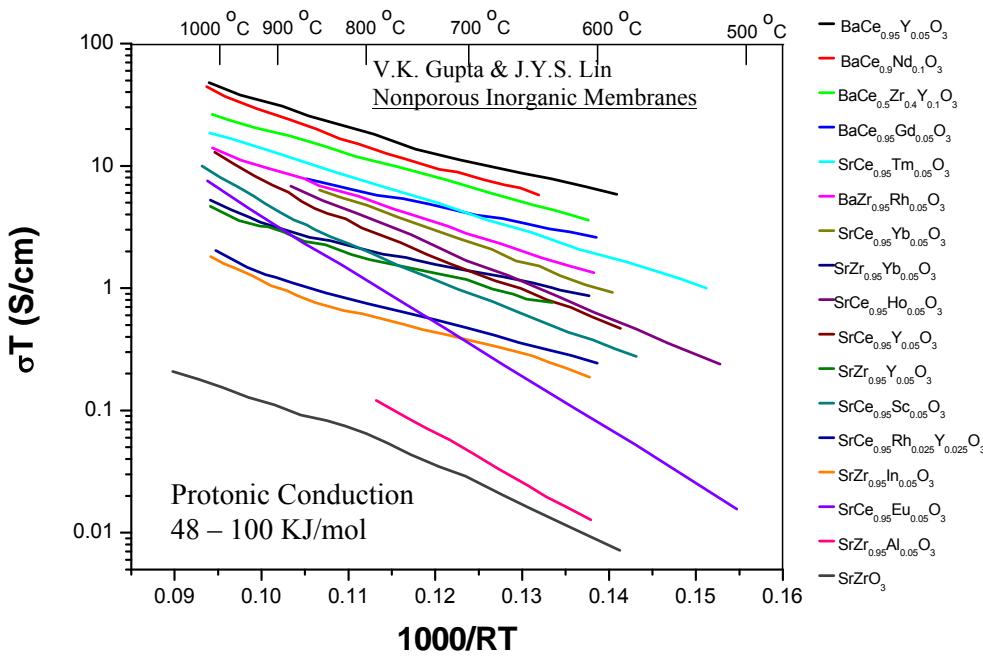
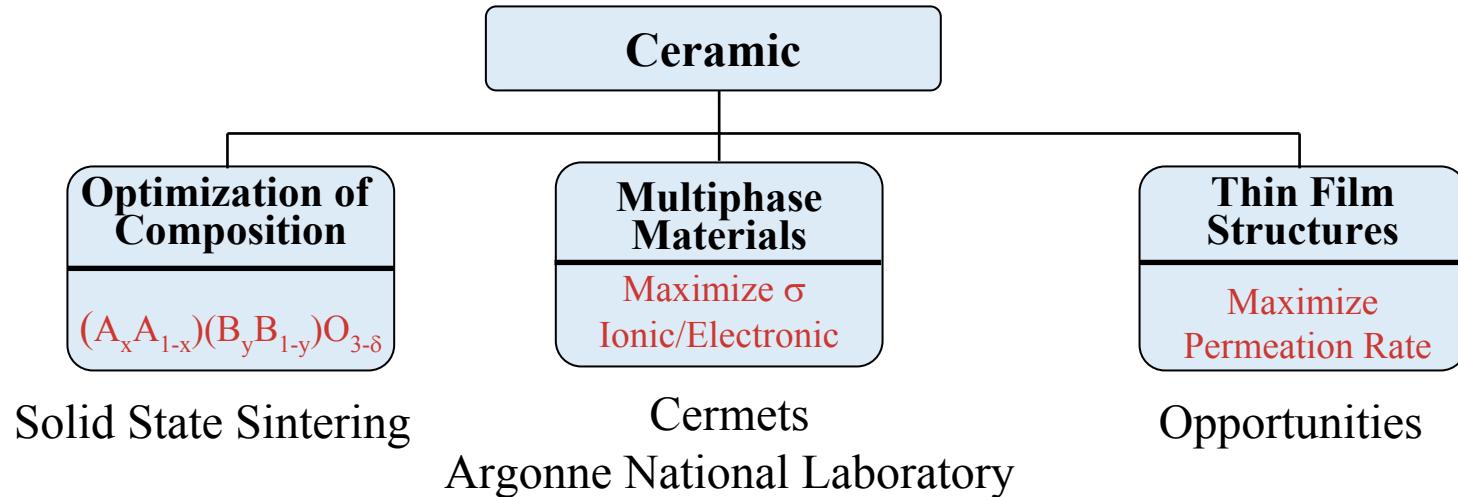


Predominant proton transfer path

Independent Oxygen sites



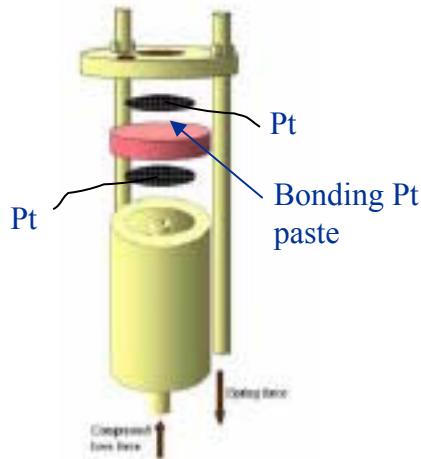
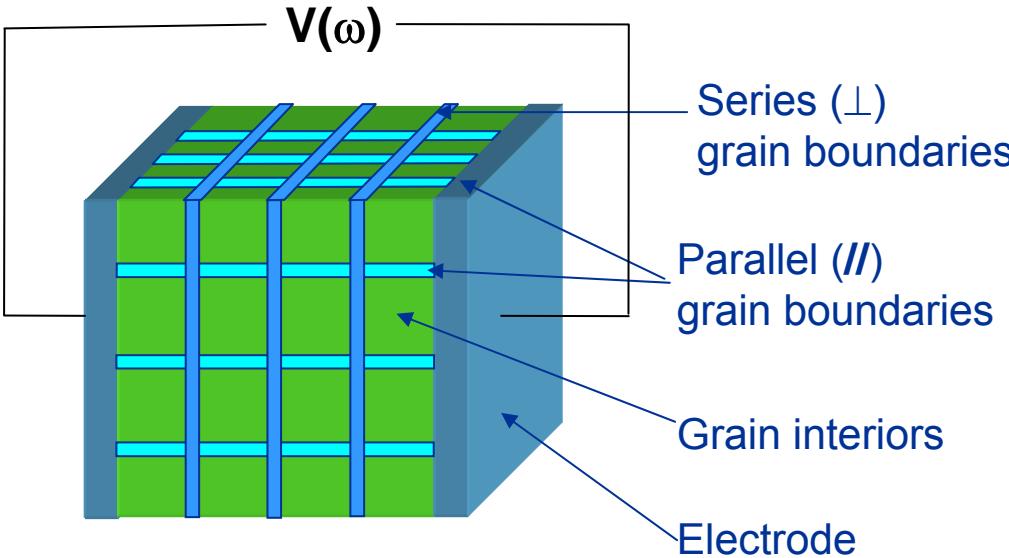
Protonic Ceramic Development



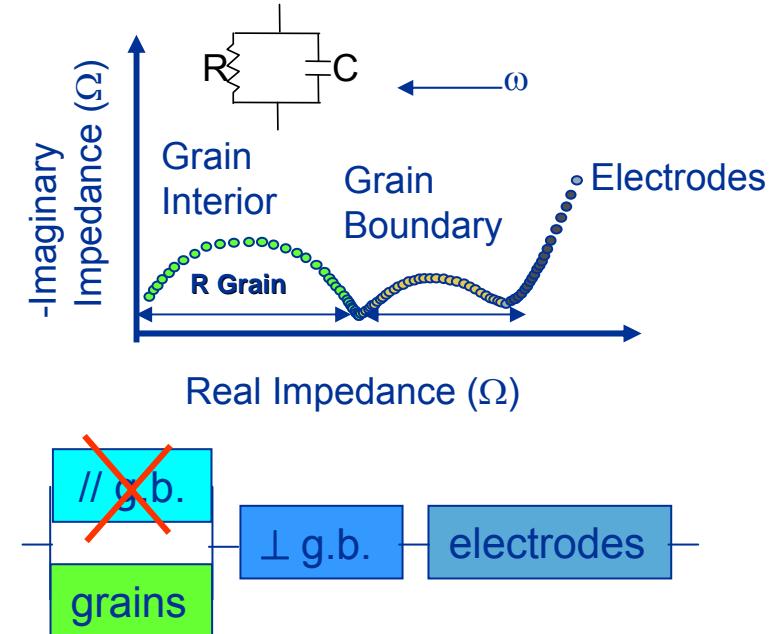
- A-Site Doping**
 - Proton Uptake
 - Chemical Stability
 - Mechanical Stability
- Basic Science**
 - Crystal Structure
 - Thermodynamics
- Grain Boundary**
 - Detrimental to H⁺ transport
- B-Site Doping**
 - O₂ Vacancies
 - Proton mobility
 - Electron σ
 - Proton Uptake
 - Chemical Stability
 - Mechanical Stability
- Environmental**
 - Reactive CO₂
 - Reactive H₂O



Impedance Spectroscopy



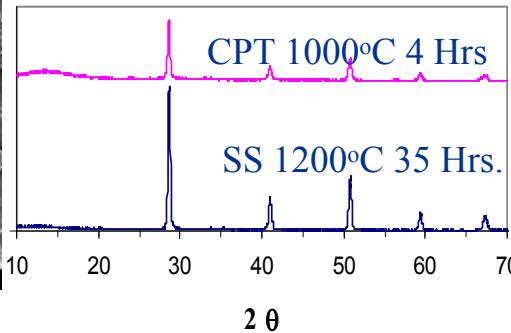
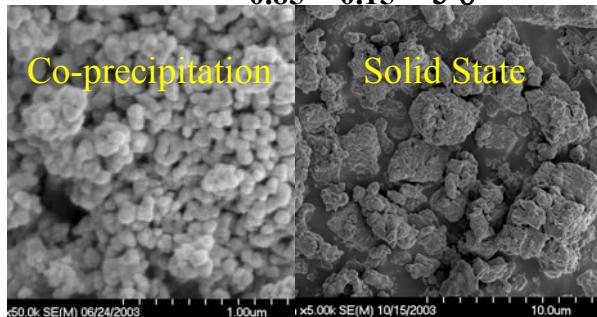
Experimental Set-Up



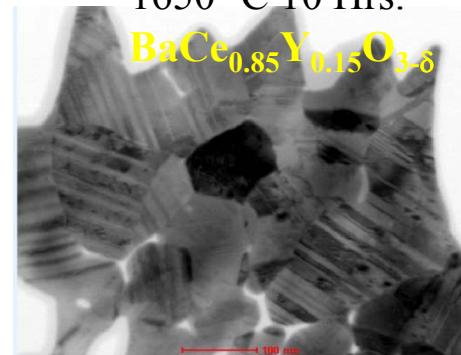
conduction: grain \neq grain boundary
 ω_0 grain boundary $\ll \omega_0$ grain-Low T
 ω_0 grain boundary $\sim \omega_0$ grain-High T



Sintering Protonic Ceramics

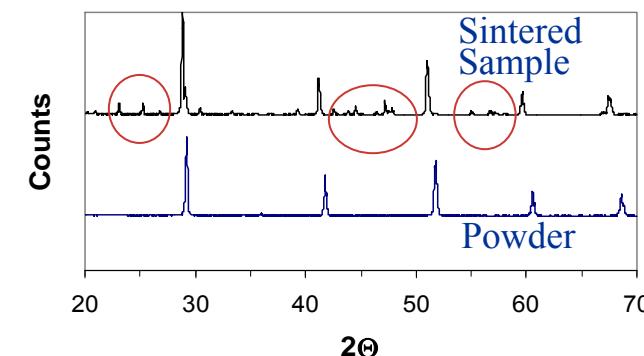
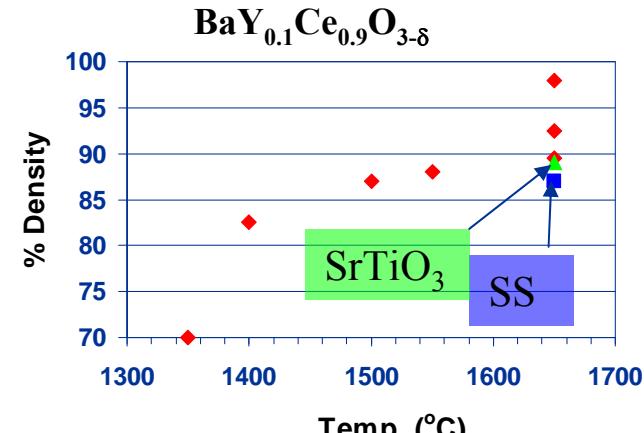


1650 °C 10 Hrs.



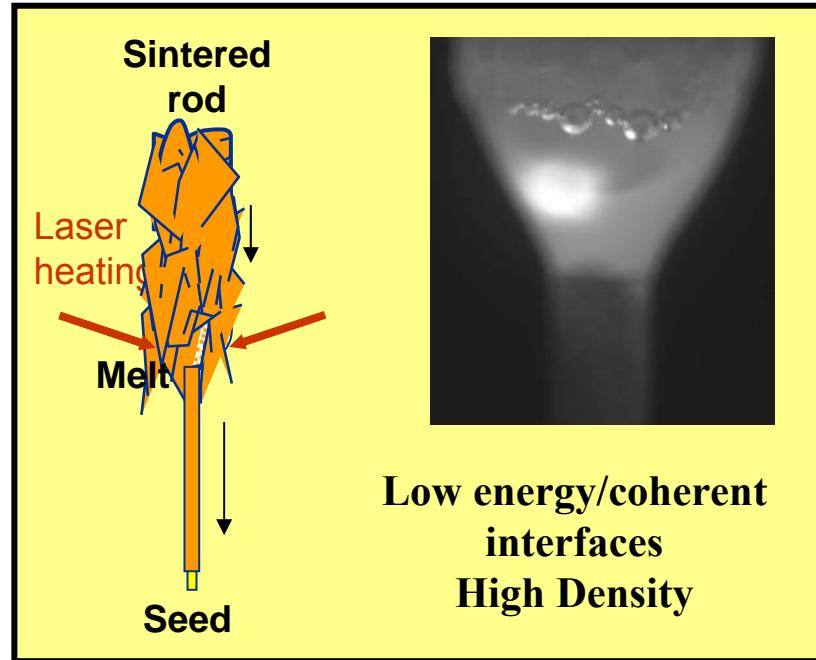
High Sintering Temp.

Composition	T °C	% ρ	Composition	T °C	% ρ
$\text{BaZr}_{1-x}\text{Y}_x\text{O}_{3-\delta}$ $x=0.02-0.25$	1700	87 - 95	$\text{SrTi}_{1-x}\text{Sc}_x\text{O}_{3-\delta}$, $x=0.02-0.05$	1590	80 - 90
$\text{BaZr}_{0.9}\text{Sc}_{0.1}\text{O}_{3-\delta}$	1700	91	$\text{Sr}_{0.66}\text{Ba}_{0.33}\text{Ti}_{0.95}\text{Sc}_{0.05}\text{O}_{3-\delta}$	1560	90
$\text{BaZr}_{0.9}\text{In}_{0.1}\text{O}_{3-\delta}$	1700	93	$\text{Sr}_{0.33}\text{Ba}_{0.66}\text{Zr}_{0.56}\text{Y}_{0.1}\text{Ti}_{0.33}\text{O}_{3-\delta}$	1600	93
$\text{BaZr}_{0.9}\text{Gd}_{0.1}\text{O}_{3-\delta}$	1650	88	$\text{Sr}_{0.66}\text{Ba}_{0.33}\text{Zr}_{0.33}\text{Sc}_{0.05}\text{Ti}_{0.61}\text{O}_{3-\delta}$	1650	88
$\text{Ba}_{0.66}\text{Sr}_{0.33}\text{Zr}_{0.9}\text{Y}_{0.1}\text{O}_{3-\delta}$	1630	88	$\text{SrZr}_{0.33}\text{Sc}_{0.05}\text{Ti}_{0.61}\text{O}_{3-\delta}$	1590	94
$\text{SrZr}_{0.9}\text{Y}_{0.1}\text{O}_{3-\delta}$	1675	94	$\text{BaZr}_{0.45}\text{Y}_{0.1}\text{Ti}_{0.45}\text{O}_{3-\delta}$	1600	87
$\text{SrHf}_{0.9}\text{Y}_{0.1}\text{O}_{3-\delta}$	1600	82			





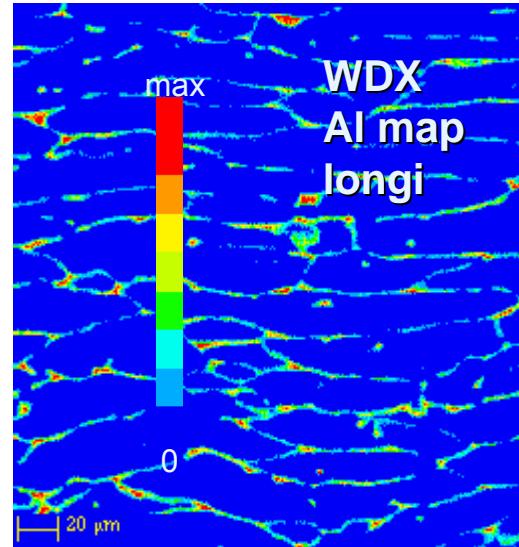
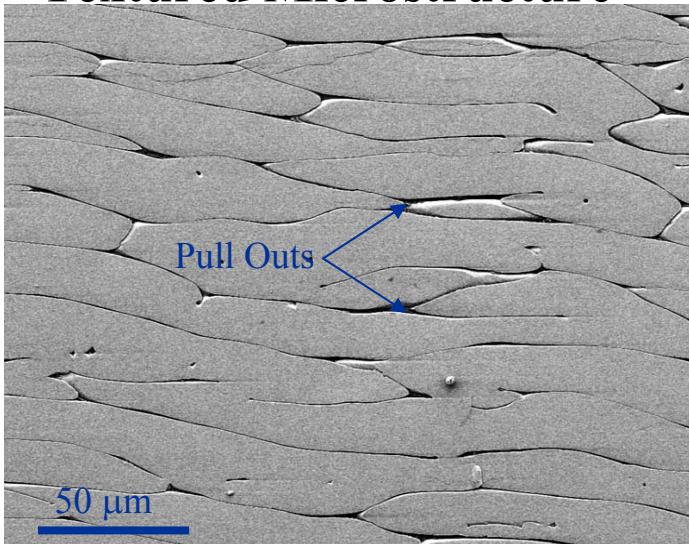
Directional Solidification





Microstructure-SrCe_{0.9}Y_{0.1}O_{3-δ} - Chemistry

Textured Microstructure

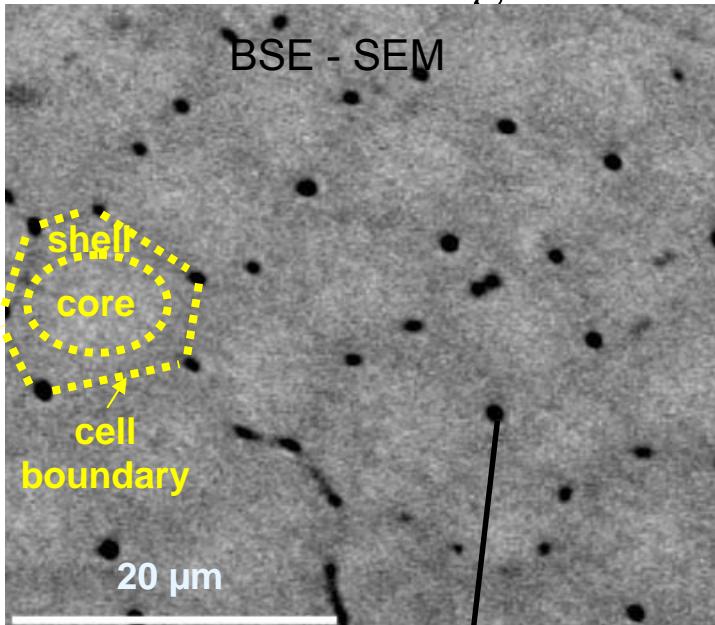


- Al 2nd phase contaminant – conc. between grains
Pre-fabrication contamination

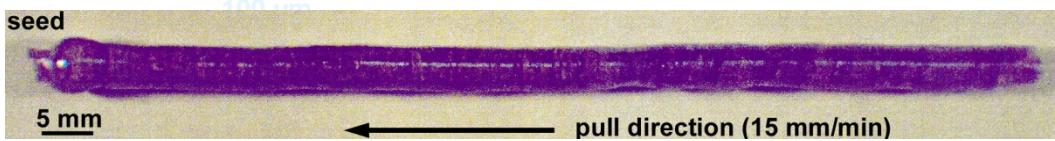
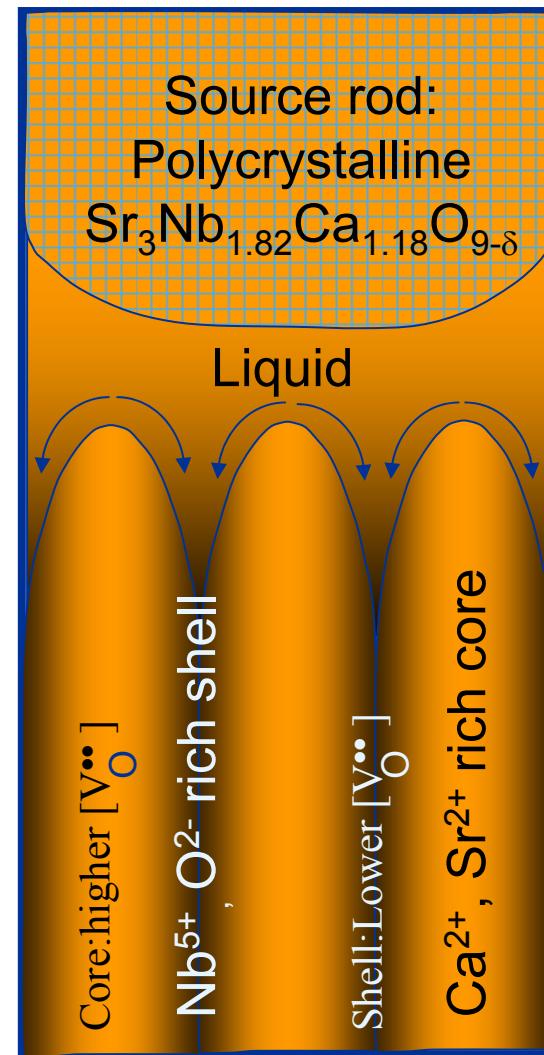


Microstructure - $\text{Sr}_3(\text{Ca}_{1+x}\text{Nb}_{2-x})\text{O}_{9-\delta}$ - Chemistry

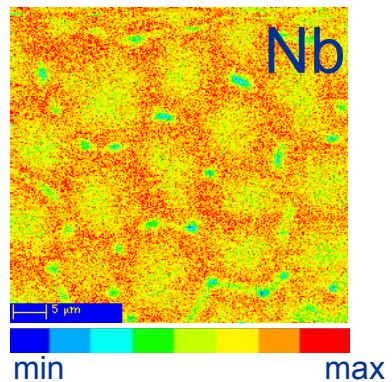
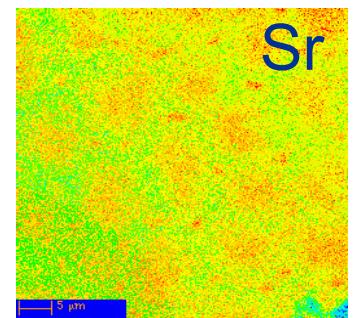
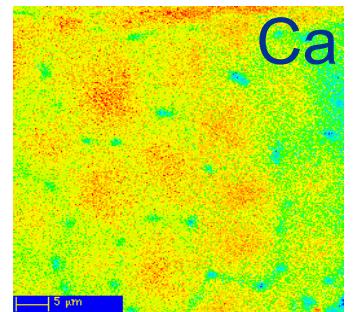
Dense - Cellular growth



Temp. gradient (+)

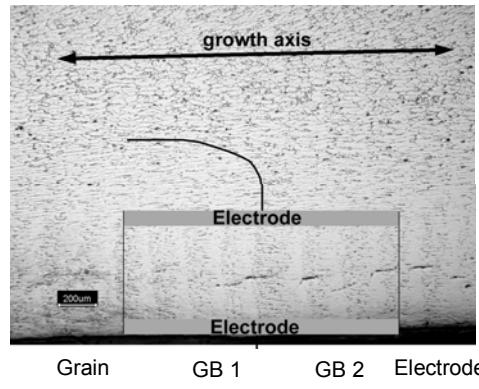
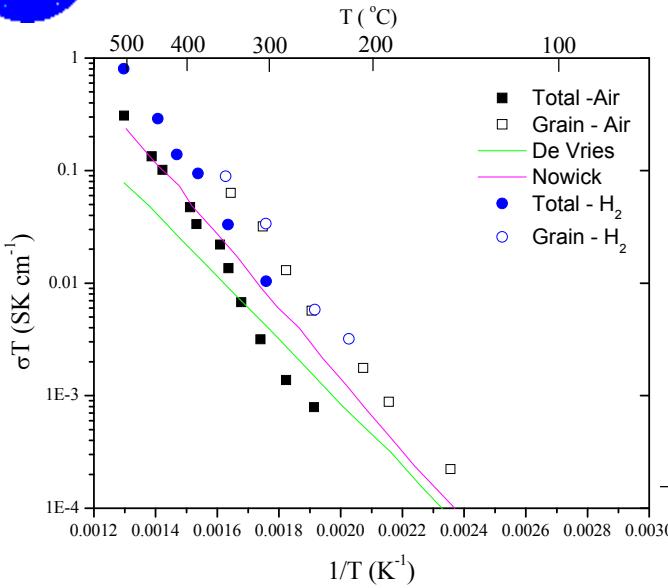


WDX maps





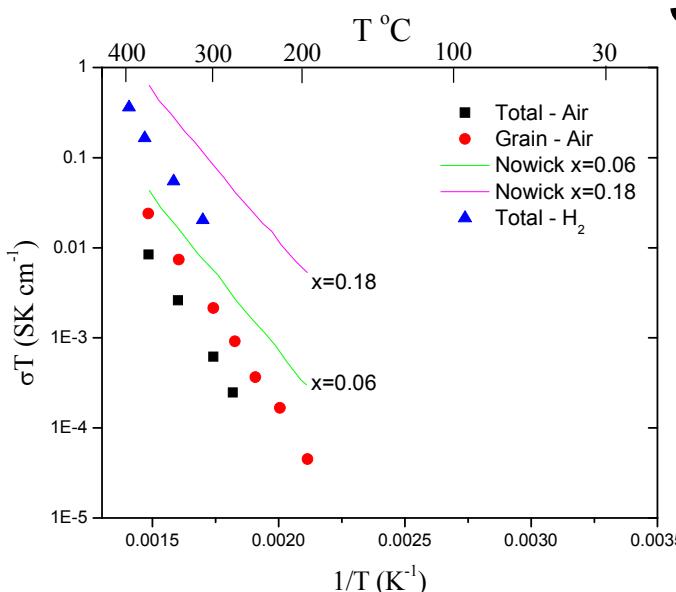
$\text{SrCe}_{0.9}\text{Y}_{0.1}\text{O}_{3-\delta}$



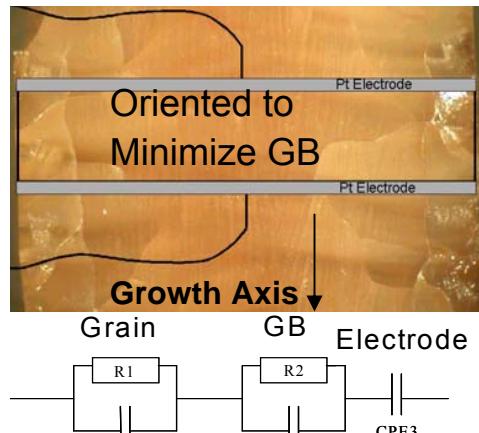
$$\sigma \cdot T = A \cdot \exp(-Q/RT)$$

Activation Energy

Total σ	Q (kJ/mol)
$\text{SrCa}_{0.9}\text{Y}_{0.1}\text{O}_{3-\delta}$ Air	83.2
H_2	98.1
De Vries	53.6
Nowick	60.8



$\text{Sr}_3(\text{Ca}_{1+x}\text{Nb}_{2-x})\text{O}_{9-\delta}$



Equivalent Circuit

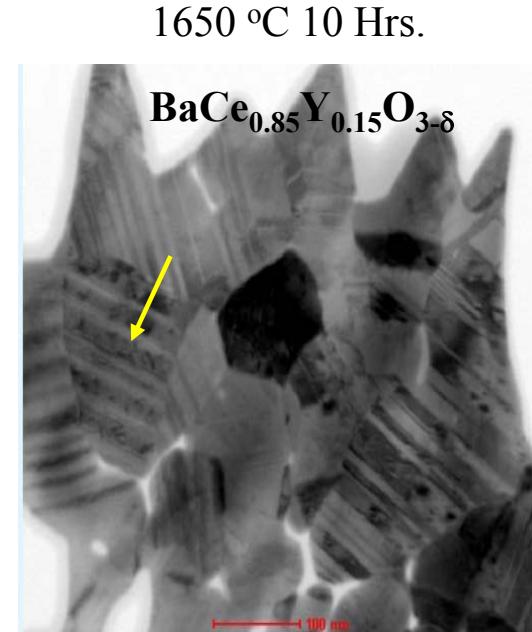
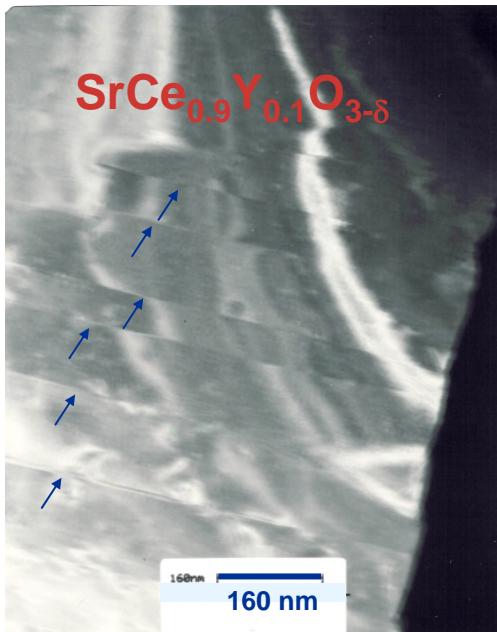
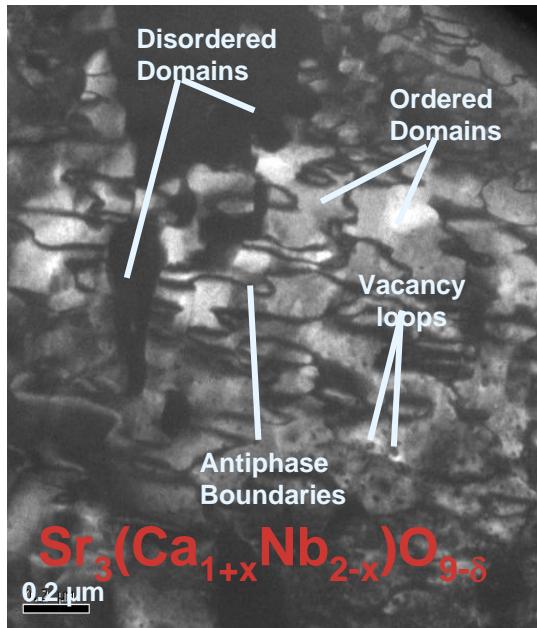
Activation Energy

Total σ	Q (kJ/mol)
$\text{Sr}_3\text{Ca}_{1.18}\text{Nb}_{1.82}\text{O}_9$ Air	84.6
H_2	98.1
Nowick $\text{Sr}_3\text{Ca}_{1.06}\text{Nb}_{1.94}\text{O}_{9-\delta}$	66.5
Nowick $\text{Sr}_3\text{Ca}_{1.18}\text{Nb}_{1.82}\text{O}_{9-\delta}$	63.6

Protonic Conduction
48 – 100 kJ/mol



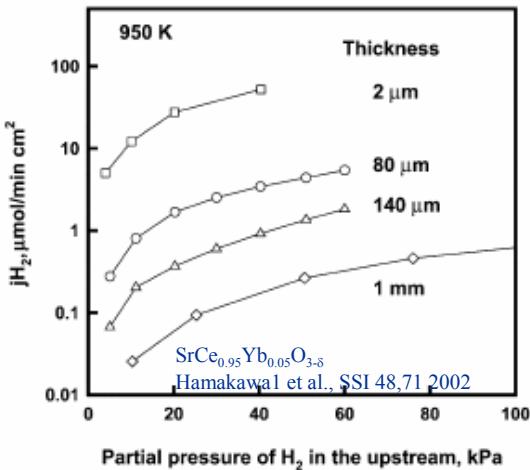
Nano-Structure Domains



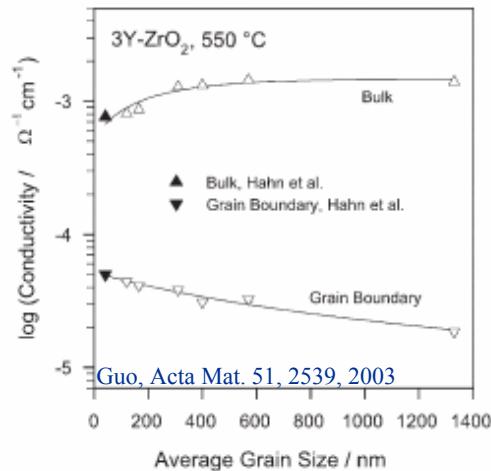
Nanostructures Protonic transport ?

Thin Film Electrolytes

Thickness Dependence

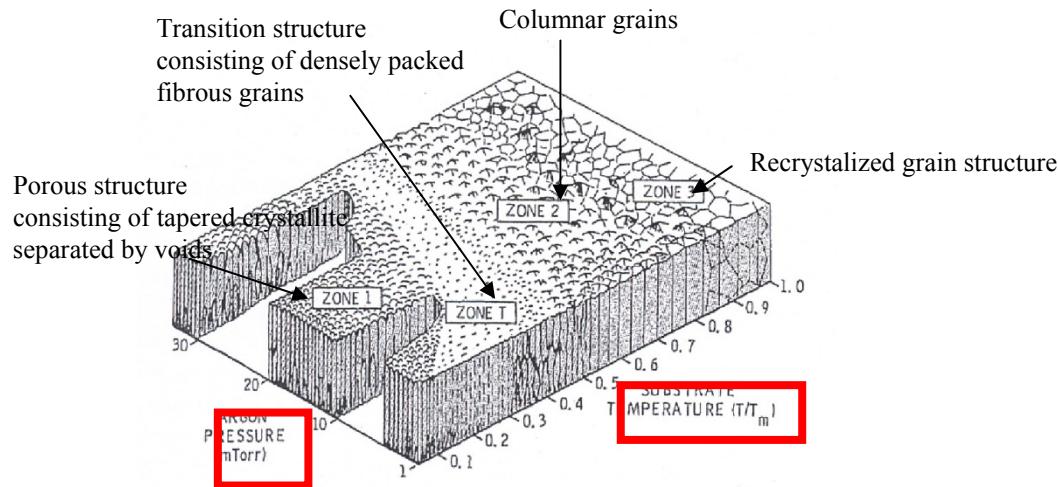


GS Dependence



Supported electrolyte fabrication difficult with high sintering temp.

PVD Microstructure



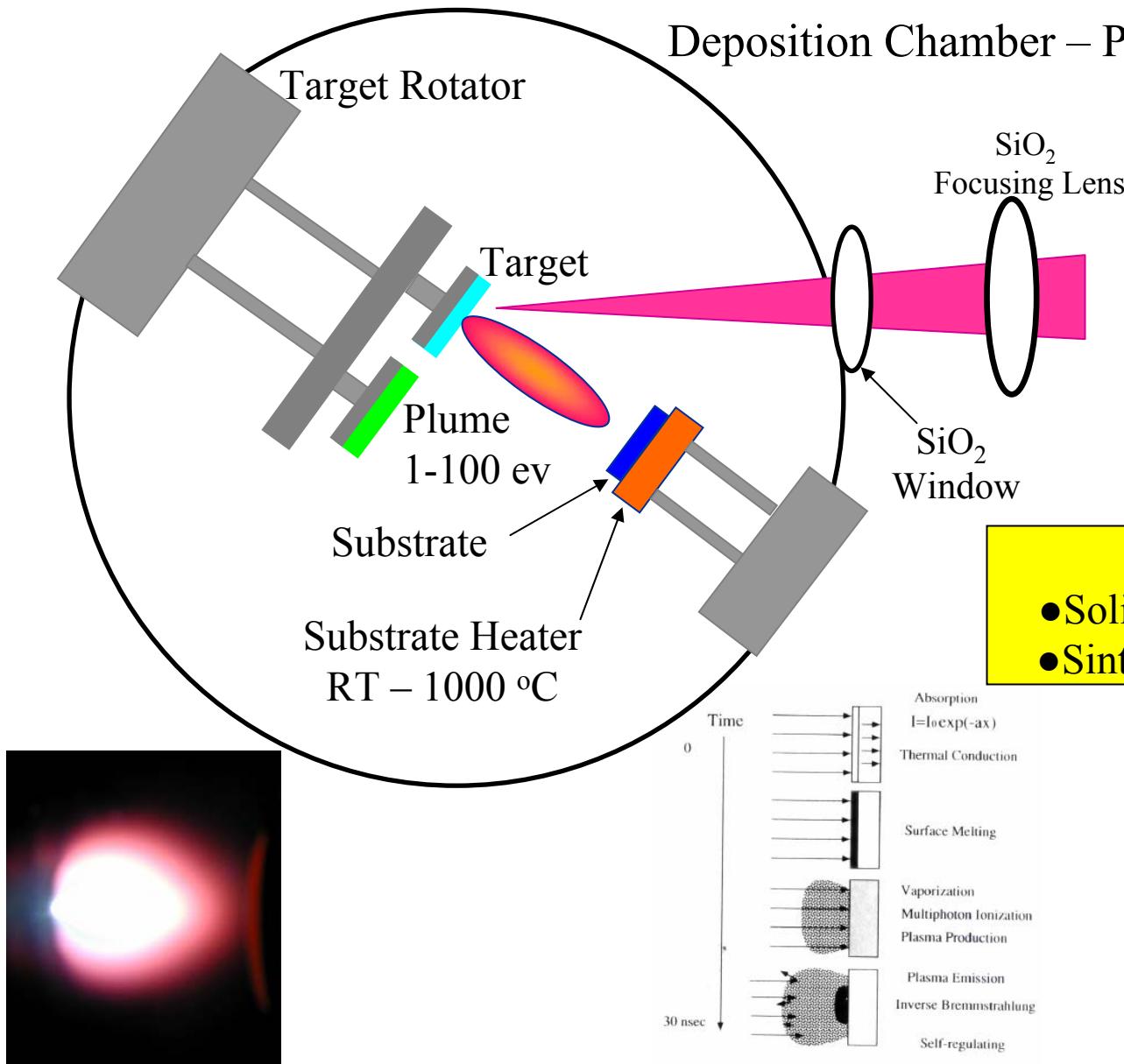
Approach

Pulsed Laser Deposition

- Stoichiometry
- Simple
- High Energy
- High Deposition Rate



Pulsed Laser Deposition



Excimer Laser

- $\lambda = 248 \text{ nm -KrF}$
- Energy: 1 – 3 J/cm^2
- Frequency: <10 Hz
- Pulse: 25 ns

Targets

- Solid state synthesize powder
- Sintering – 1650 °C 10 hrs. air

Substrates

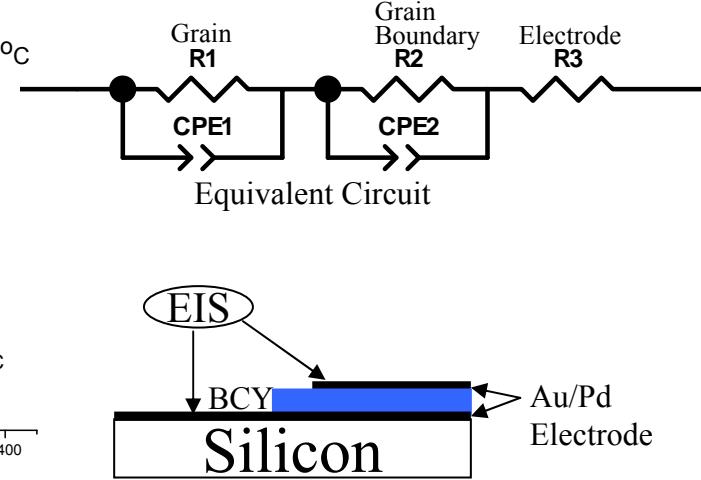
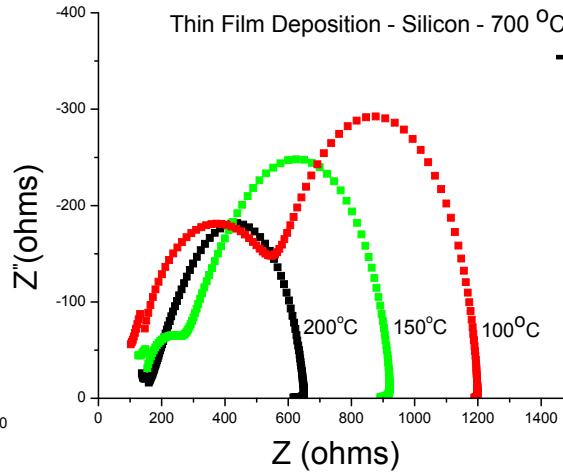
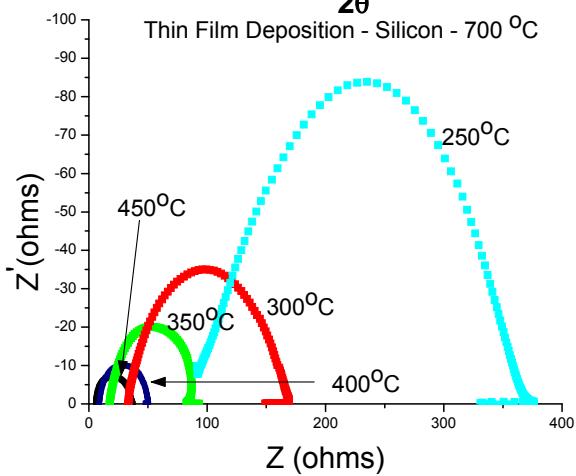
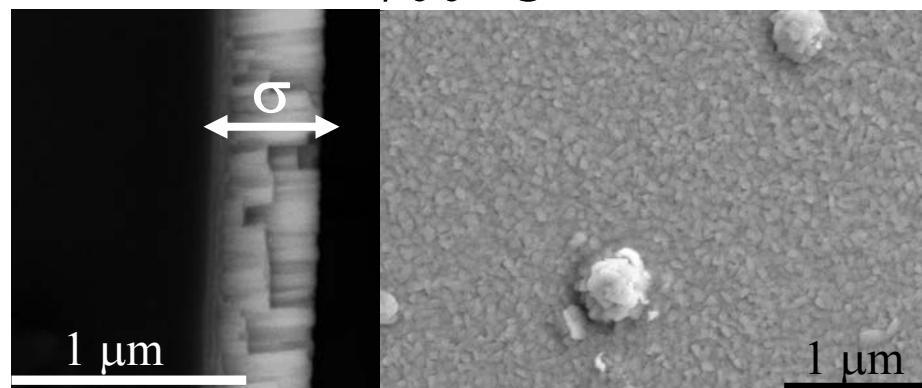
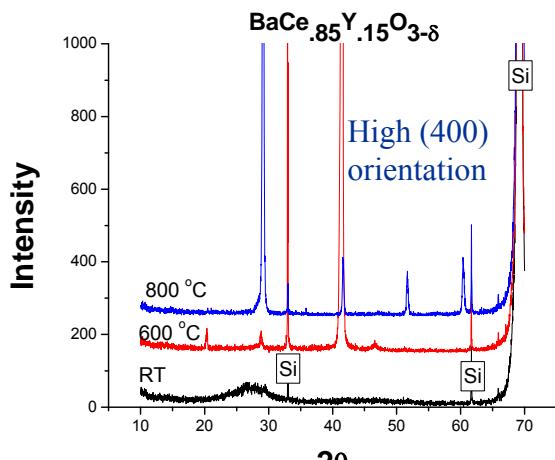
- Porous Al_2O_3
- Porous BaZrO_3
- Silicon



Silicon Substrates

$\text{BaCe}_{0.85}\text{Y}_{0.15}\text{O}_{3-\delta}$

700 °C



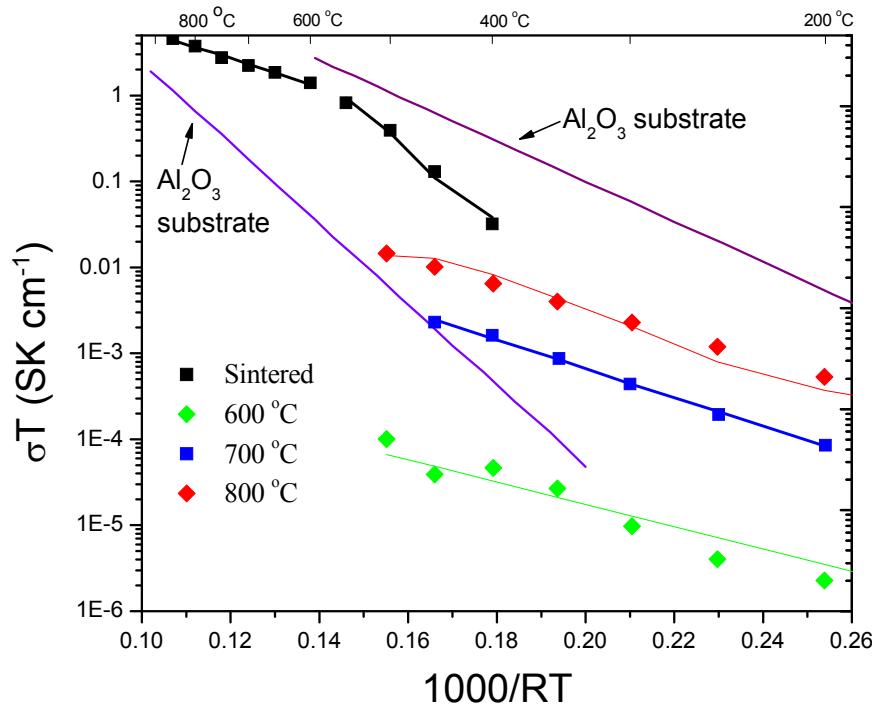
Solartron 1260/1287
Moist Argon – 25 °C

0.1 – 1MHz
Zplot/Zview Software

100 °C – 500 °C



Total Conductivity Silicon Substrates



$$\sigma \cdot T = A \cdot \exp(-Q/RT)$$

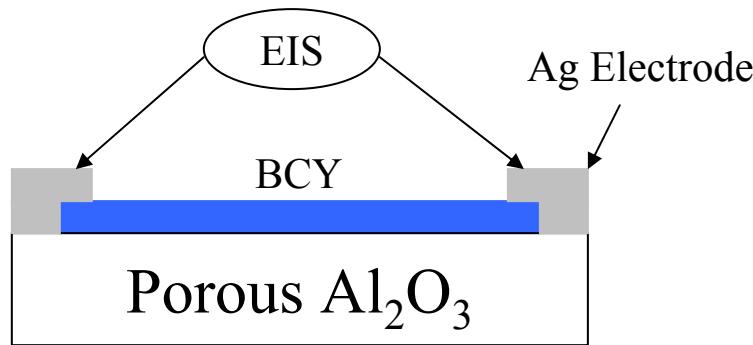
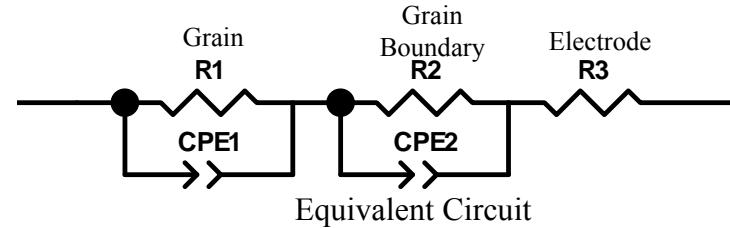
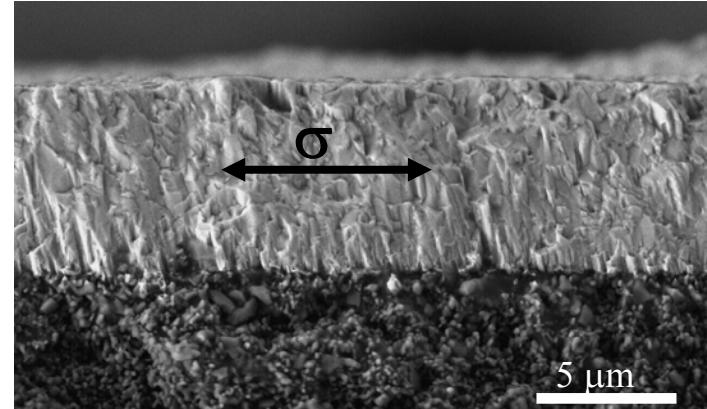
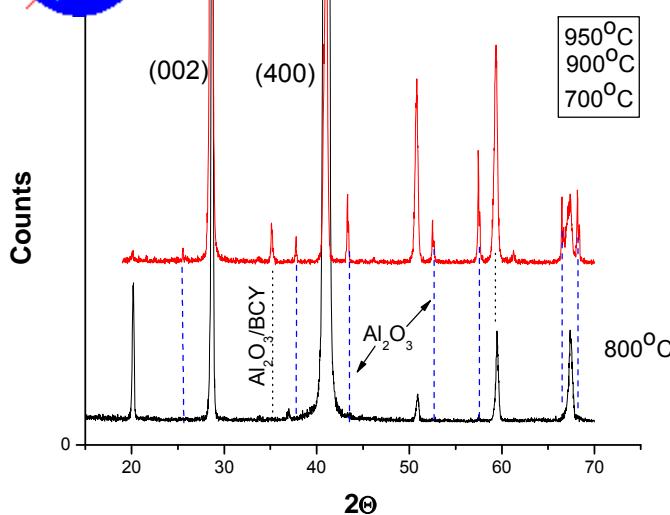
Activation Energy

	Temp. (°C)	Q (KJ/mol)	Film Thickness (μm)
BaCe _{0.85} Y _{0.15} O ₃ Sintered	600 - 850 400 - 550	38.6 100.3	
800 °C/30 mT	100 - 500	33.4	6
700 °C/30 mT	200 - 500	38.2	6
600 °C/30 mT	100 - 500	29.9	2.4

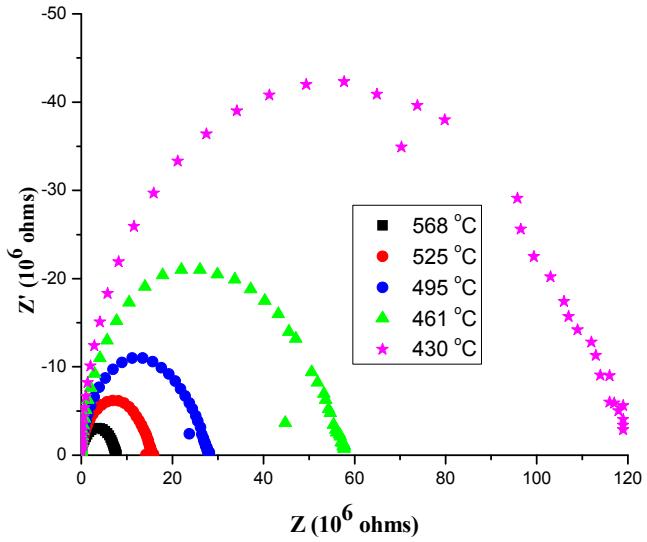
Protonic Conduction – 48 – 100 KJ/mol



Porous Al₂O₃ Substrates



Solartron 1260/1296 0.1 – 1MHz 100 °C – 950 °C
Air – 25 °C Zplot/Zview Software

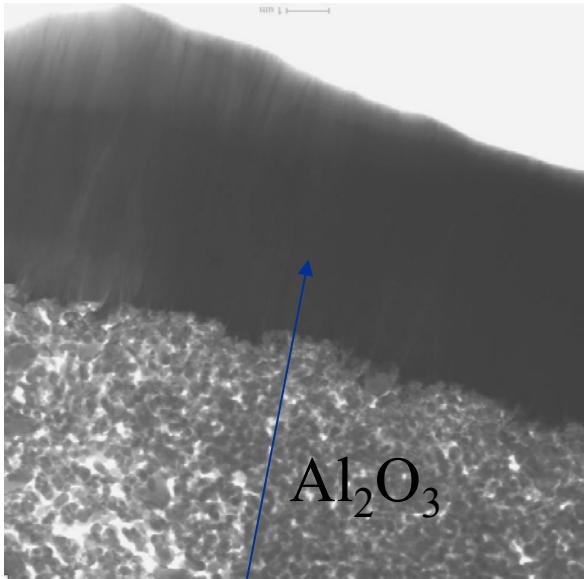


Microstructure Characterization



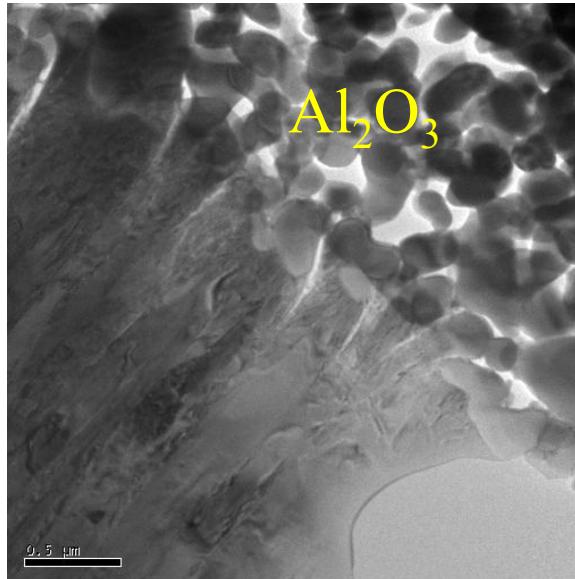
$\text{BaCe}_{0.85}\text{Y}_{0.15}\text{O}_{3-\delta}$ Film

800 °C Deposition Temperature



Dense films
fabricated at 600-950
°C

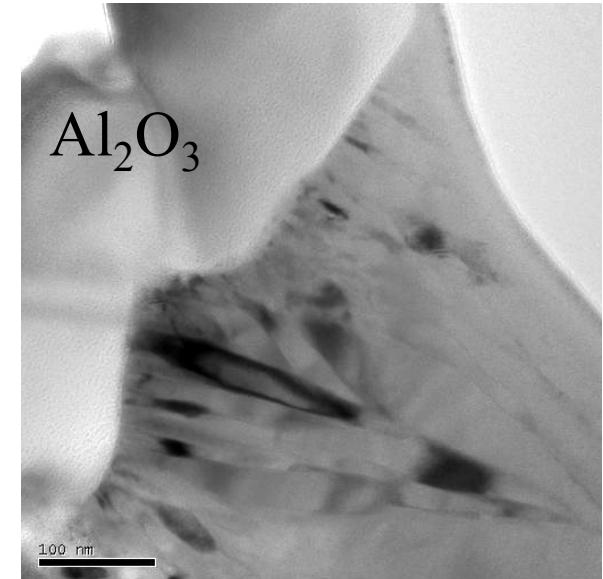
No inclusions from
PLD



Al_2O_3 particles determine
column width.

Dense films form by
impinging column growth.

No long range defects



Numerous BCY nano-
crystals nucleate at the
 Al_2O_3 particle surface.

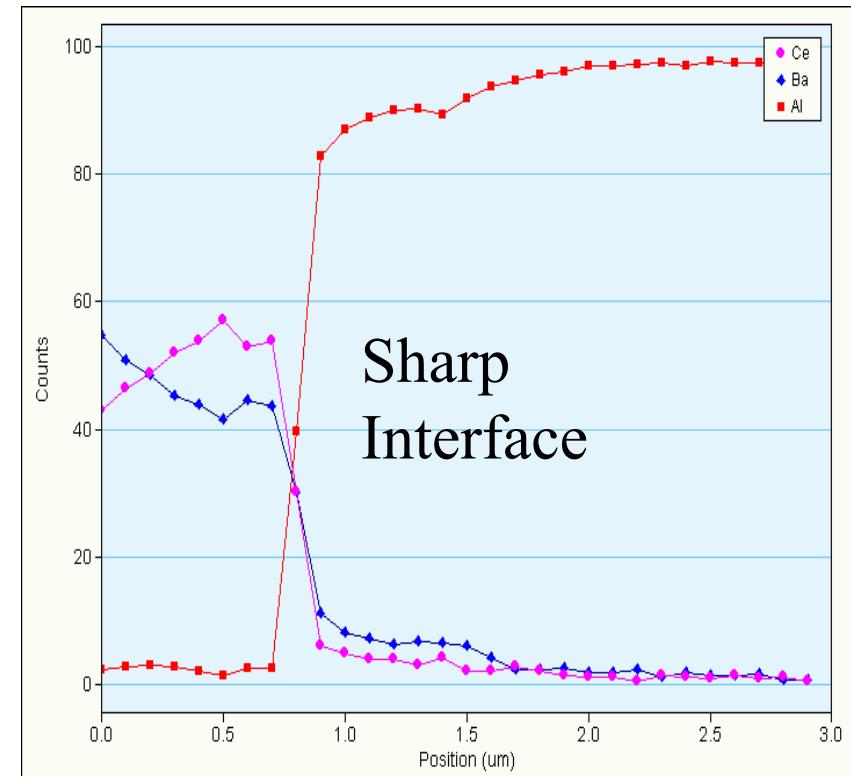
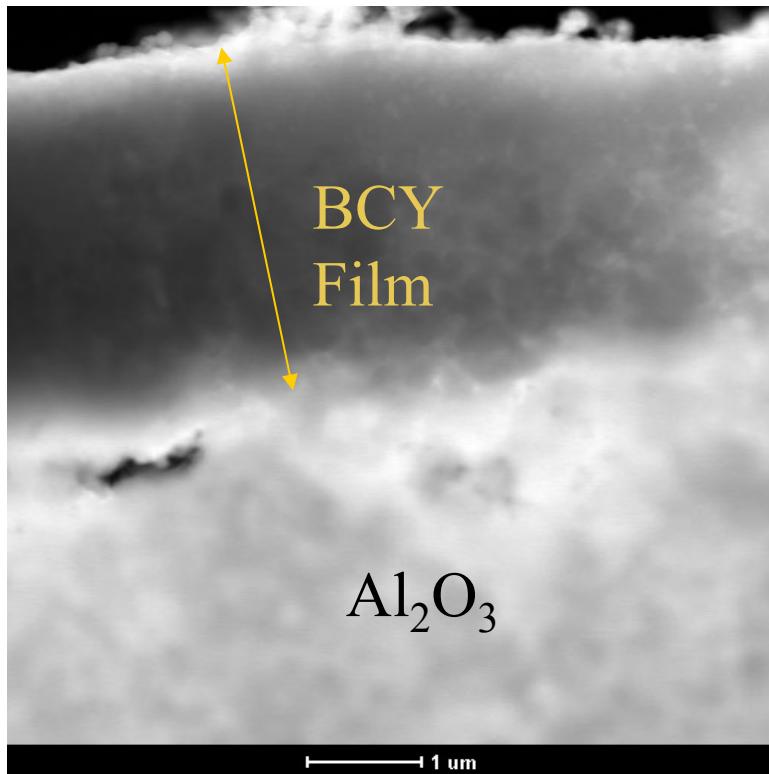
Thin amorphous layer



Interface Characterization

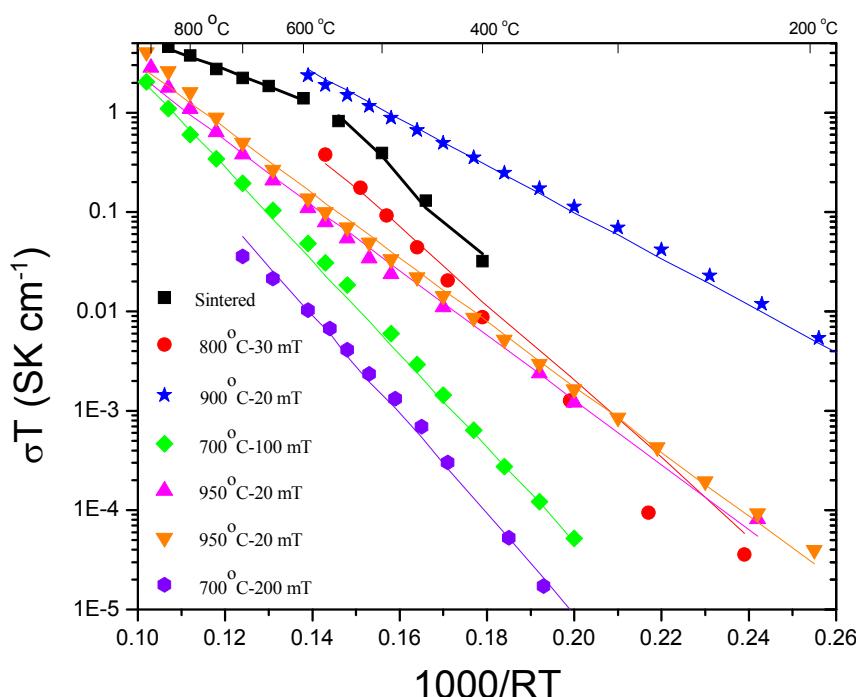
$\text{BaCe}_{0.85}\text{Y}_{0.15}\text{O}_{3-\delta}$ Film

950 °C Deposition Temperature





Total Conductivity Porous Al₂O₃ Substrates



$$\sigma \cdot T = A \cdot \exp(-Q/RT)$$

Activation Energy

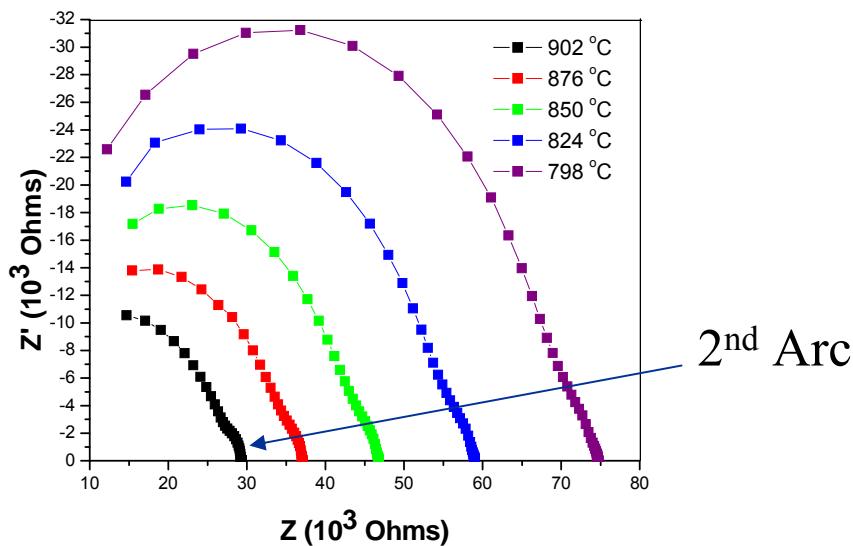
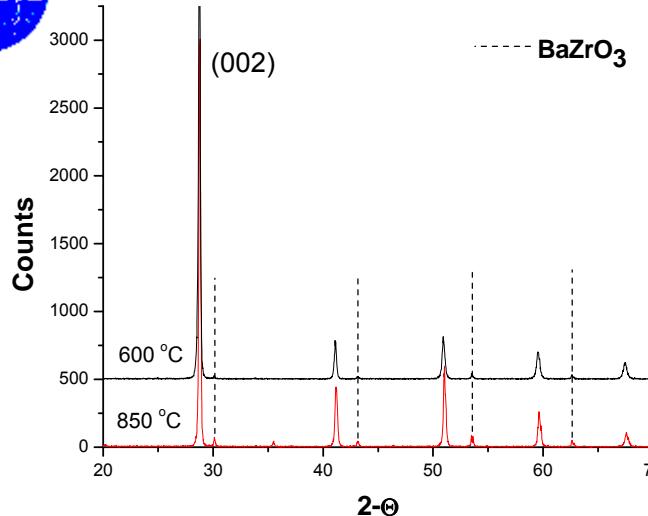
	Temp. (°C)	Q (KJ/mol)	Film Thickness (μm)
BaCe _{0.85} Y _{0.15} O ₃ Sintered	600 - 850 400 - 550	38.6 100.3	
950 °C/30 mT	200 - 900	74.8	3.6
950 °C/30 mT	200 - 900	75.4	3.2
900 °C/30 mT	200 - 600	54.1	4.8
800 °C/30 mT	200 - 600	98.1	3.6
700 °C/100 mT	350 - 900	115.6	1.7
700 °C/200 mT	350 - 700	108.2	4.1

Protonic Conduction – 48 – 100 KJ/mol

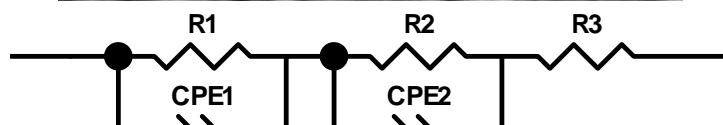
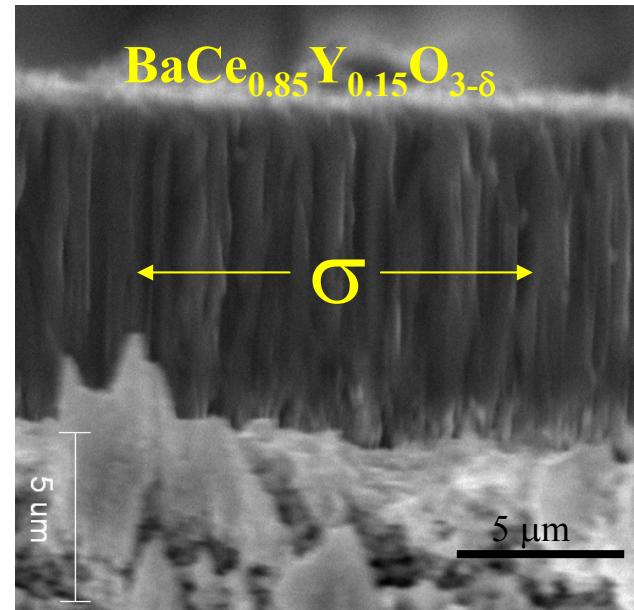
Conduction exhibits large dependence on process conditions.



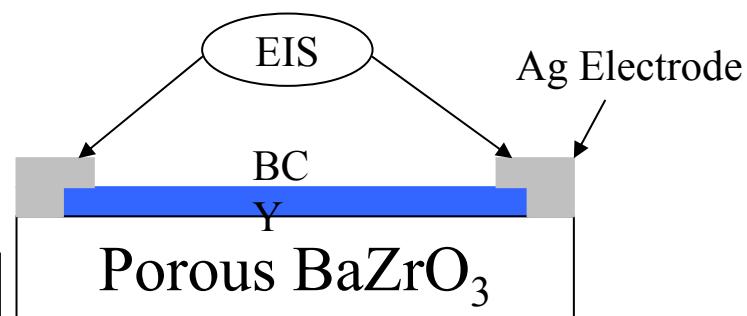
Porous BaZrO₃ Substrates



Solartron 1260/1296 0.1 – 1MHz 100 °C – 950 °C
Air, 5%H₂/N₂ Zplot/Zview Software



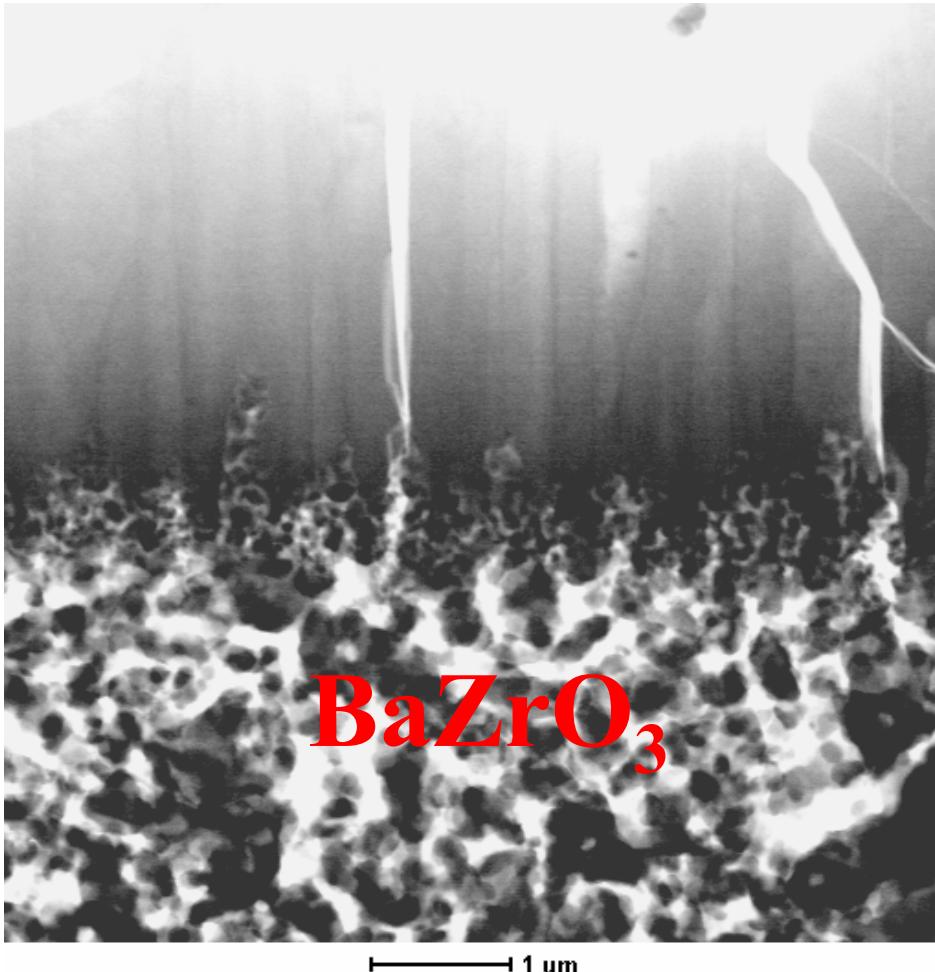
Equivalent Circuit



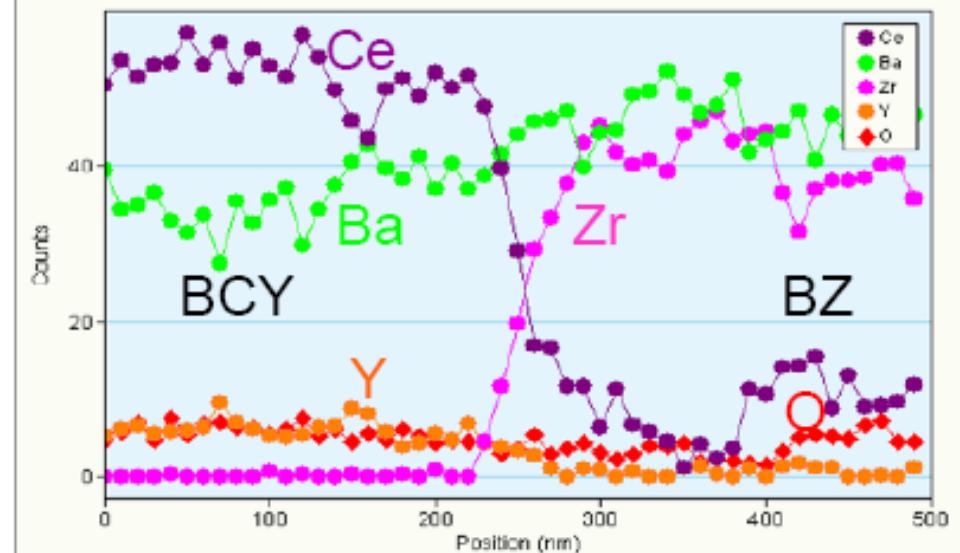
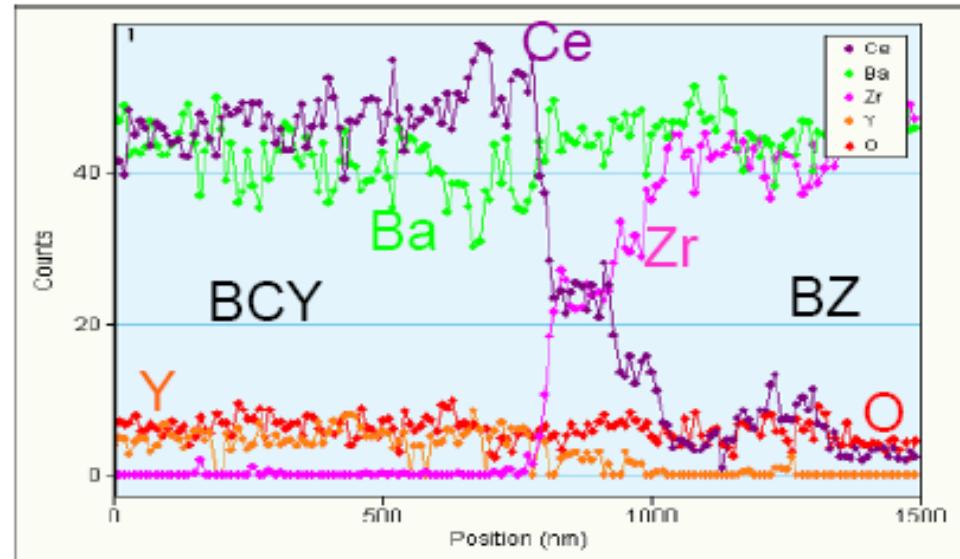
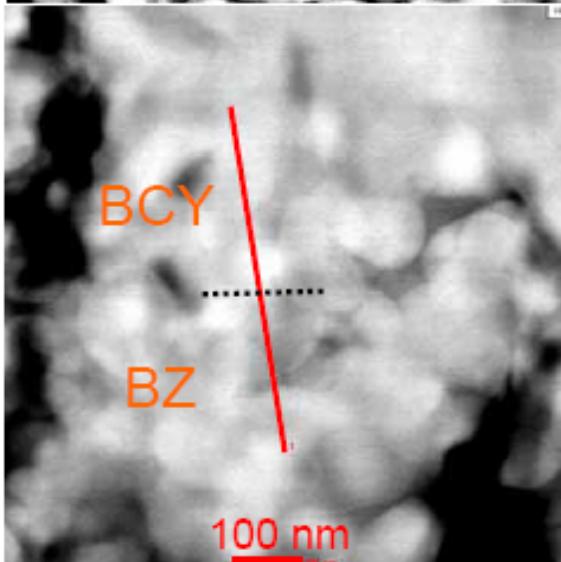
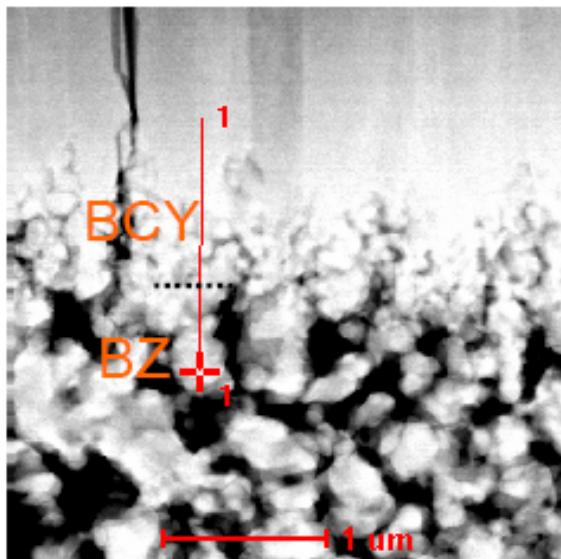


Microstructure Characterization

$\text{BaCe}_{0.85}\text{Y}_{0.15}\text{O}_{3-\delta}$ Film

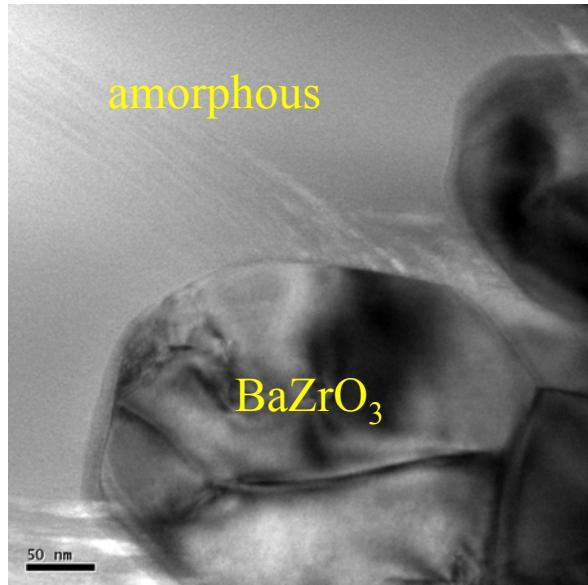
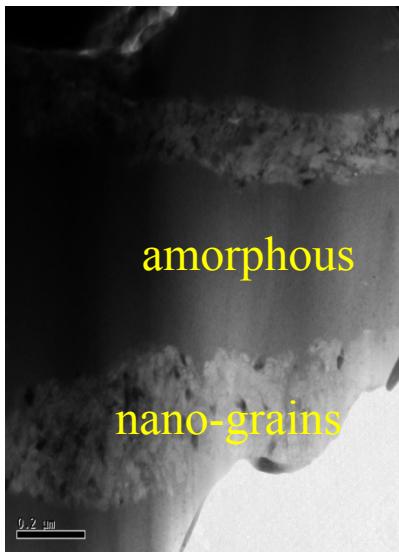


- Columnar grains
- No particle inclusions from PLD
- Low defects
- No long range ordering

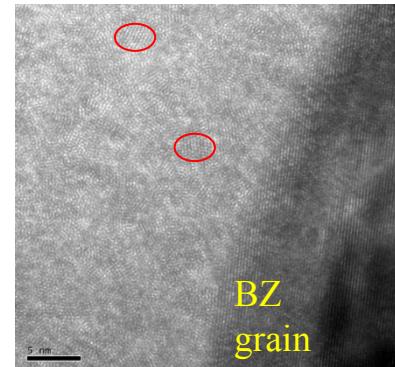




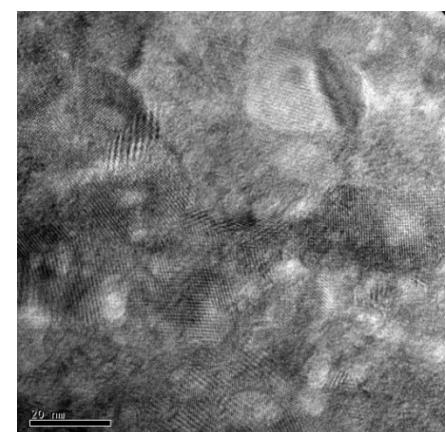
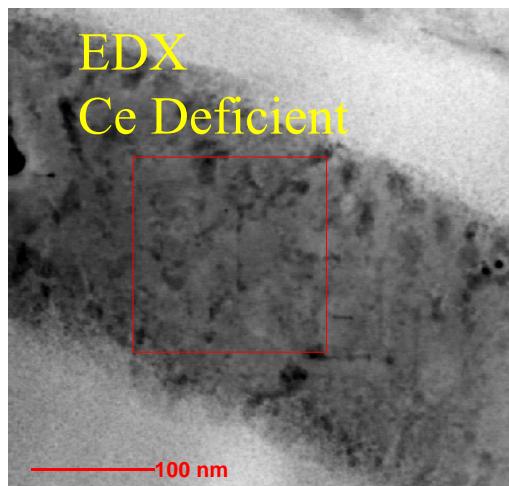
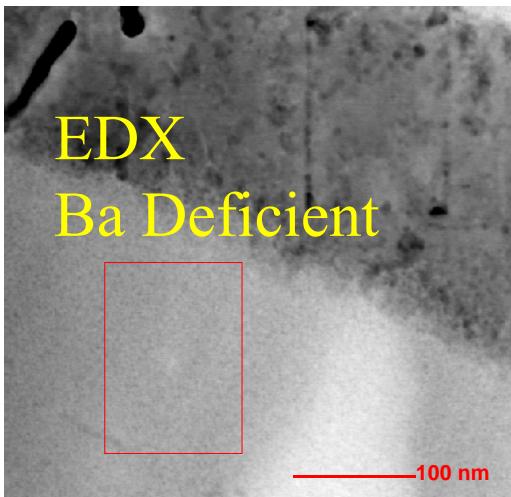
Growth Segregation



Small domains 2 nm visible
3.1 Ang ... make the continuous circle



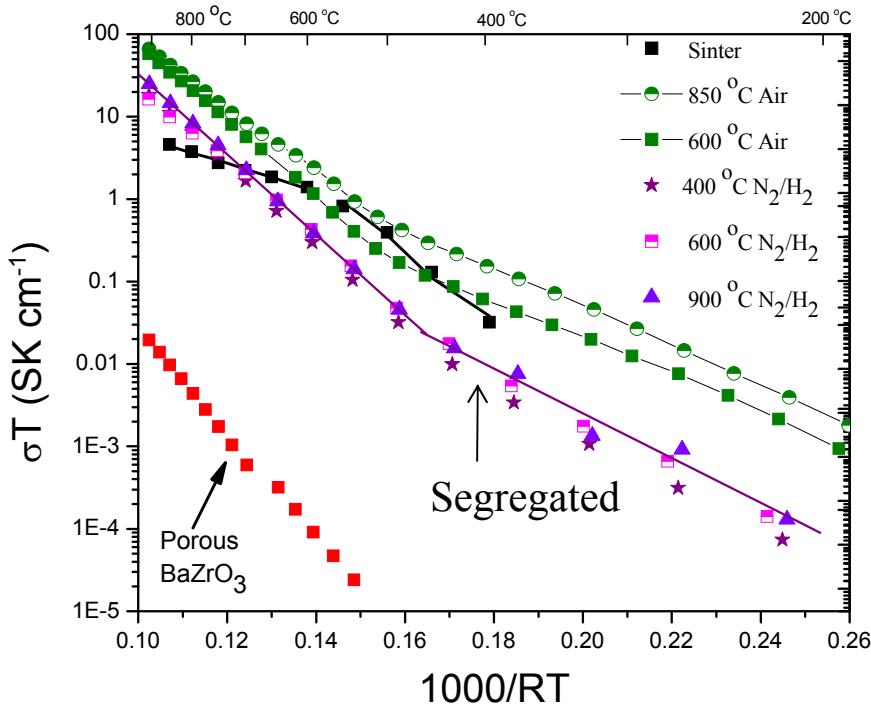
~20 nm grains





Total Conductivity Porous BaZrO₃ Substrates

BaCe_{0.85}Y_{0.15}O_{3-δ}



$$\sigma \cdot T = A \cdot \exp(-Q/RT)$$

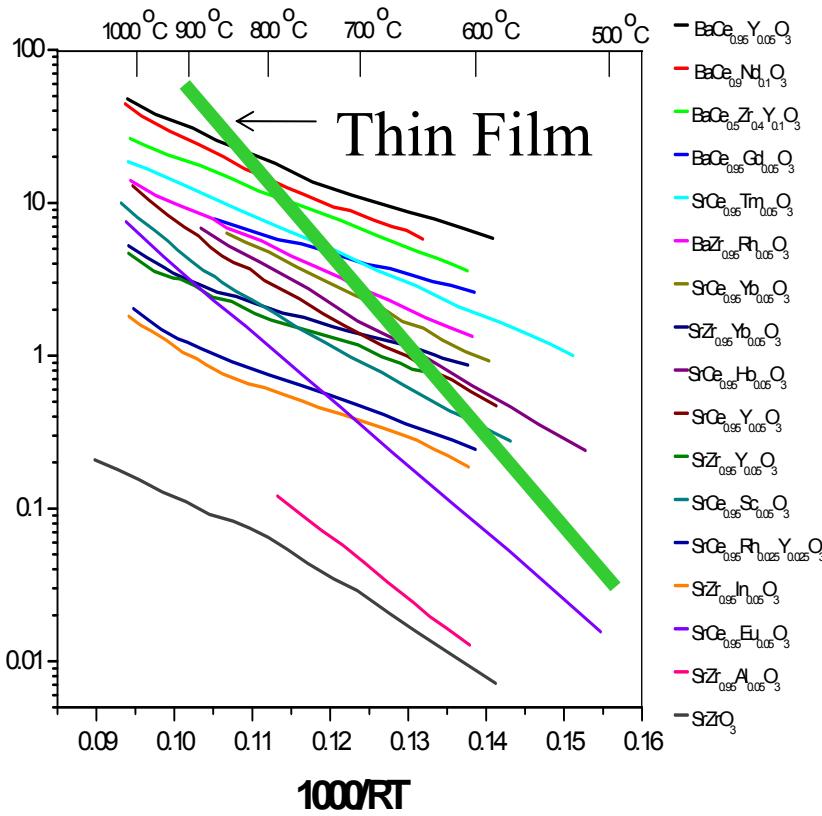
Activation Energy

	Temp. (°C)	Q (kJ/mol)	Film Thickness (μm)
BaCe _{0.85} Y _{0.15} O ₃ Sintered	$600 - 850$ $400 - 550$	38.6 100.3	
850 °C/20 mT	$550 - 900$ $100 - 550$	89.7 56.8	9.4
600 °C/30 mT	$550 - 900$ $100 - 550$	106.7 55.2	5.9
400 °C/20 mT	$550 - 900$ $100 - 550$	111.5 48.1	3.8
600 °C/20 mT	$550 - 900$ $100 - 550$	102.9 45.7	1.0
900 °C/20 mT	$550 - 900$ $100 - 550$	112.2 62.5	3.1

- σ less dependent upon process conditions
- Conduction change at $T > 550^\circ\text{C}$

Summary

σT (S/cm)



- Directionally solidified samples exhibit similar ionic conduction to reported data for sintered samples.
- Directional solidification produces nano-sized structural defects. Influence of defects on proton mobility remains unknown.
- Directional solidification can produce unique microstructures that can not be achieved by solid state sintering.
- Dense protonic films can be fabricated on porous substrates by PLD in the temperature range of 600-950 °C.
- Columnar growth morphologies are observed at temperature <950 °C. Process dependent oriented crystal growth occurs among the [100] and [001] directions.
- Matching crystal symmetry between substrate & film is essential to maximize protonic conduction.